



1765
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Emmanuel Hadji et al.

Serial No.: 09/673,005

Art Unit: 1765

Filed: November 27, 2000

Title: METHOD FOR FORMING AN OPTICAL SILICON LAYER ON A
SUPPORT AND USE OF SAID METHOD IN THE PRODUCTION
OF OPTICAL COMPONENTS

Examiner: Shamim Ahmed

Docket No.: 33019

AMENDMENT "A"
(In response to Paper No. 7)

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Commissioner for Patents
Washington, D.C. 20231

Sir:

This amendment is filed in response to the Office action dated August 19, 2002. The three (3) month period for responding to the Office Action expired on November 19, 2002. Accordingly, applicants respectfully request and petition that the response date be extended, for one (1) month, to December 19, 2002. The \$110.00 extension of time fee is enclosed.

Please amend the above-identified application in the following manner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington D.C. 20231 on the date indicated below.

Suzanne B. Gagnon

Name of Attorney for Applicant(s)

December 19, 2002

Date

Signature of Attorney

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